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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF:

Kenichi HAMA, et al.

GROUP: 1762

SERIAL NO: 10/511,607

FILED: November 4, 2004

EXAMINER: CHEN, BRET P

FOR: METHOD AND DEVICE FOR CLEANING RAW MATERIAL GAS  
INTRODUCTION TUBE USED IN CVD FILM FORMING APPARATUS

**SUBMISSION OF SUPPLEMENTAL APPLICATION DATA SHEET**

Office of Initial Patent Examination  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant(s) submit herewith a Supplemental Application Data Sheet for the above-identified application for the purpose of correcting the 1<sup>st</sup>, 2<sup>nd</sup> and 4<sup>th</sup> inventors' cities of residence

Respectfully Submitted,

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